

Docket No.: PHCF-04015
HIR:096



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Mitsuru Hasegawa, et al.

Serial No.: 10/803.087

Group Art Unit: 1763

Filing Date: March 18, 2004

Examiner: Unknown

For: SEMICONDUCTOR FILM FORMATION DEVICE

Honorable Commissioner of Patents
Alexandria, VA 22313-1450

SUBMISSION OF PRIORITY DOCUMENT

Sir:

Submitted herewith is a certified copy of Japanese Application Number 2003-072909
filed on March 18, 2003, upon which application the claim for priority is based.

Respectfully submitted.

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